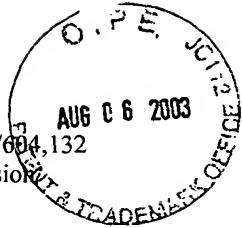


App. No. 10/604,132  
IDS Submission



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

App. No. : 10/604,132  
Applicant : Masuhiro Natsuhara et al.  
Filed : June 27, 2003  
Title : WAFER HOLDER FOR SEMICONDUCTOR  
MANUFACTURING DEVICE AND SEMICONDUCTOR  
MANUFACTURING DEVICE IN WHICH IT IS  
INSTALLED  
Tech. Cntr./Art Unit : (to be assigned)  
Examiner : (to be assigned)  
Docket No. : 39.016-AG

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

This constitutes an Information Disclosure Statement pursuant to 37 C.F.R. §§ 1.97 and 1.98. The attached documents as listed on the accompanying Form PTO/SB/08A are hereby brought to the Examiner's attention in the patent application identified above. A copy of this form accompanies this paper.

**Concise Explanation of the Relevance/Copy of Translation**  
**Pursuant to 37 C.F.R. § 1.98(a)(3)(i)&(ii)**

Abstracts in English, prepared by Patent Abstracts of Japan, of non-English references JP H04-78138 and JP H13-118664 are readily available to the applicant through the Japanese Patent Office Web site, and are attached to the respective fronts of these Japanese documents.

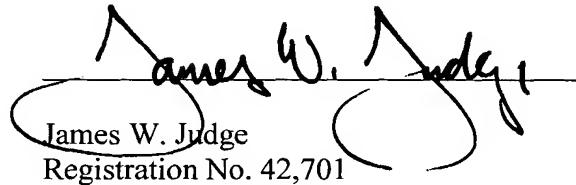
App. No. 10/604,132  
IDS Submission

A concise explanation of the relevance of Japanese references JP H04-78138 and JP 2001-118664 is incorporated into the specification in the present application, in paragraphs 0005 and 0006 respectively. Furthermore, machine-translated abstracts thereof, available through the Japanese Patent Office Web site, are attached to the front of each reference.

The Examiner is respectfully requested to consider these references, and to indicate so on the accompanying Form PTO/SB/08A and make the document of record in the present application.

Respectfully submitted,

July 30, 2003



James W. Judge  
Registration No. 42,701

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